

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Jiro KONDO, et al.
Serial No. : 10/591,093
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For : METHOD FOR REMOVING BORON FROM SILICON
Examiner : Cohen, Stefanie J.
Art Unit : 1793
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I hereby certify this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on October 5, 2009.

Signature: /Katy Chan-Parsons/
Katy Chan-Parsons

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

In response to the Office Action dated April 9, 2009, Applicants respectfully request entry of the following amendments and comments into the file of the above-identified application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 5 of this paper.